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APPLICANTS					•				
Toshihiko Kitoku, Nirasaki-shi, JAPAN;									
Shinji Niwa, Nirasaki-shi, JAPAN; Toshiki Hosaka, Kofu-shi, JAPAN;Takashi Kitazawa, Nirasaki-shi, JAPAN; Atsuo Sanda, Oita-shi, JAPAN; Yoshitaka Sato, Yokohama-shi, JAPAN;									
** CONTINUING DATA **********************************									
** FOREIGN APPLICATIONS ************************************									
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Foreign Priority claimed		Ø yes □ no		STATE OR	SHE	ETS	TOT	AL	INDEPENDENT
35 USC 119 (a-d) cond met Verified and	litions	Allowance Net after		COUNTRY		WING	CLAI		CLAIMS
Acknowledged	Exa		tials	JAPAN		3	13		2
ADDRESS 22850 OBLON, SPIVAK, MCCLELLAND, MAIER & NEUSTADT, P.C. 1940 DUKE STREET ALEXANDRIA, VA 22314									
TITLE Vacuum processing apparatus and substrate transfer method									
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